

2815



Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Koichiro TANAKA  
Serial No. 09/774,637  
Filed: February 1, 2001  
For: BEAM HOMOGENIZER LASER  
IRRADIATION APPARATUS,  
SEMICONDUCTOR DEVICE, AND  
METHOD OF FABRICATING THE  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2815  
) Examiner: J. Diaz  
) CERTIFICATE OF MAILING  
) I hereby certify that this correspondence is being  
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AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 18, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.